

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in Re Application of	I hereby certify that this correspondence is bei	ng
Nakamura	deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents,	rst .
Serial No.: 10/809,118	P.O. Box 1450, Alexandria, VA 22313-1450 on	
Filed: March 25, 2004) (Date of Deposit) Shannon Wallace	
For: Semiconductor Device And Manufacturing Method Thereof	Name of applicant, assignee, or Registered Rep. Signature Date	_
Art Unit:)	
Examiner: Unknown)	

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

STATUS INQUIRY

Gentlemen:

Please advise as to the status of the above-identified patent application.

More than two (2) years have passed since Applicants filed this application.

Accordingly, the Applicants respectfully requests the current status of the above-identified patent application.

Respectfully submitted,

Dated: Ocher 2, 2006

Mark J. Murphy
Attorney of Record
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